

TFW 1752



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q62193

Kenichiro SATO, et al.

Appln. No.: 09/729,953

Group Art Unit: 1752

Confirmation No.: 7258

Examiner: John S Y CHU

Filed: December 6, 2000

For: POSITIVE TYPE PHOTORESIST COMPOSITION

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 31, 2006, please consider the remarks as submitted herewith on the accompanying pages.

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